

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 10/820,575  
Filing Date ..... April 7, 2004  
Inventor ..... Scott E. Moore et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2877  
Examiner ..... Roy Punnoose  
Attorney's Docket No. .... MI22-2493  
Title: Semiconductor Workpiece Processing Methods and Turbidity Monitoring  
Methods

**RESPONSE TO JUNE 16, 2006 OFFICE ACTION**

To: Mail Stop Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)  
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Sir:

This is a response to the Office Action dated June 16, 2006, Applicants amend  
and remark as follows:

**AMENDMENTS**